



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Donald L. Yates

Serial No.: 10/027,951

Filed: December 19, 2001

For: METHOD OF REDUCING WATER SPOTTING AND OXIDE GROWTH ON A

SEMICONDUCTOR STRUCTURE

Confirmation No.: 2633

Examiner: A. Markoff

Group Art Unit: 1746

Attorney Docket No.: 2269-3375.6US

(95-0999.5)

Notice of Allowance Mailed:

August 30, 2004

Express Mail Mailing Label No.:

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Date of Deposit with USPS:

November 30, 2004

Person making Deposit:

Steve Wong

OK 10 enter 0K pm/105 03/01/05

## AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

Amendments to the Specification begin on page 3 of this paper.